



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Dennison et al.

Serial No.: 10/020,741

Filed: December 12, 2001

For: OPTIMIZED CONTAINER
STACKED CAPACITOR DRAM CELL
UTILIZING SACRIFICIAL OXIDE
DEPOSITION AND CHEMICAL
MECHANICAL POLISHING

Confirmation No.: 2283

Examiner: Tuan H. Nguyen

Group Art Unit: 2813

Attorney Docket No.: 2269-3259.1US
(91-0473.02/RE)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First-Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

1/21/04
Date

Doreen Neumann
Signature

Doreen Neumann
Name (Type/Print)

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed October 21, 2003, the three-month shortened statutory period for response to which expires on January 21, 2004.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

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